



Inventor: Garo J. Derderian  
Serial No. 10/676,169  
Title: Deposition Methods  
Assignee: Micron Technology, Inc.  
Docket No. MI22-2373

**INFORMATION DISCLOSURE STATEMENT**


References – See Attached Form PTO-1449

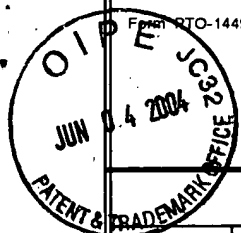
The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. Copies are not attached (1276 Off.Gaz.Pat.Off 55, 05 August 2003). No admission is made regarding whether any of the submitted references is prior art.

Respectfully submitted,

Dated: 04 Jun 2004

Attorney: \_\_\_\_\_

  
James E. Lake  
Reg. No. 44,854



Form PTO-1449

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEATTY. DOCKET NO.  
MI22-2373SERIAL NO.  
10/676,169LIST OF ART CITED BY APPLICANT  
(Use several sheets if necessary)APPLICANT  
Garo J. DerderianFILING DATE  
September 30, 2003GROUP  
1762

## U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	6,060,383	05/2000	Nogami et al			
	AB	6,258,690	07/2001	Zenke			
	AC	6,596,636	07/2003	Sandhu			
	AD	6,630,201	10/2003	Chiang et al			
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						

## FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclasses	Translation	
							Yes	No
	AM							
	AN							
	AO							
	AP							
	AQ							

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AR		
	AS		
	AT		

EXAMINER

DATE CONSIDERED

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.